

IN THE CLAIMS

B2 12. (New) The magnetic thin film in accordance with Claim 1 wherein said iron nitride thin film is formed on an iron under layer on said substrate.

13³. (New) The magnetic thin film in accordance with Claim 2 wherein said iron nitride thin film is formed on an iron under layer on said substrate.

REMARKS

Claims 1, 2, 10, and 11 stand pending in the present application.

5 The specification and title have been objected to. A new title has been entered, following the Examiner's suggestion, along with the disclosure now reciting a specific reference to the prior parent U. S. application. Applicant submits that with the change to the specification, the claim for priority has been perfected. Applicant respectfully requests the objections to the specification to be withdrawn.

10 Formal drawings will be forwarded upon indication of allowable subject matter.

15 Claims 1 and 2 stand objected to because of the following informality recited by the Examiner, "these claims with respect to all limitations given patentable weight are held to be identical with respect to the film formed. The method of forming the film is not germane to the issue of patentability of the film